



PATENT  
USSN 10/727,429  
Atty. Docket No. 8448-90969

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: ) Confirmation No. 6834  
Ghanshyam S. Mishra et al. )  
For: NEW REACTOR FOR PRODUC- ) Examiner: Alvin T. Raetzsch  
ING LOWSURFACE AREA HIGH/ )  
LOW STRUCTURE CARBON )  
BLACK AND SIMUTANEOUSLY )  
MINIMIZING THE FORMATION )  
OF GRIT )  
Serial No. 10/727,429 )  
Filed: December 4, 2003 )

AMENDMENT A UNDER RULE 111

Mail Stop Amendment  
Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Examiner's action mailed on April 4, 2006, applicants request that the application be amended as follows:

I hereby certify that this paper is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop \_\_\_\_\_ Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this date.

9/15/06 2 in Wex  
Date Registration No. 24,550  
Attorney for Applicant(s)